AMENDMENT TRANSMITTAL LE Applicant(s): Chong Was	Docket No. PSS.0027US		
Serial No 10/081,080 JUN 9 2002 February 21, 2002	Examiner Unassigned	Group Art Unit	
Invention: INTEGRATED INDUCTIVE CIRCUIT	rs	TECHNOLO ST. C.	

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING		HIGHEST #		NUMBER EXTRA	RATE		ADDITIONAL
	AFTER AME	NDMENT	PREV. PAI	D FOR	CLAIMS PRESENT	RAIE		FEE
TOTAL CLAIMS	21	-	20	=	1	x	\$18.00	\$18.00
INDEP. CLAIMS	4	-	4	=	0	Х	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable)						\$0.00		
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$18.00		

	Nο	additional	fee is	required	for	amendment.
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☐ Please charge Deposit Account No.

in the amount of

A duplicate copy of this sheet is enclosed.

- A check in the amount of \$18.00
- to cover the filing fee is enclosed.
- The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 20-1504 A duplicate copy of this sheet is enclosed.
 - Any additional filing fees required under 37 C.F.R. 1.16.
 - Any patent application processing fees under 37 CFR 1.17.

Dated: 6/12/12

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I certify that this document and fee is being deposited on June 1 2 with the U.S. Postal Service as

Signature of Person Mailing Correspondence

Cynthia L. Hayden





NITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Chong Woo

Art Unit:

2811

Serial No.:

10/081,089

Examiner:

Unassigned

Filed:

February 21, 2002

For:

INTEGRATED INDUCTIVE

CIRCUITS

Atty Docket: PSS.0027US

Commissioner for Patents Washington, DC 20231

PRELIMINARY AMENDMENT

Sir:

Prior to the receipt of an office action in the above-referenced application, please amend the above-referenced patent application as follows:

IN THE CLAIMS

Please amend claim 1 as follows:

1 (Amended). A method comprising:

forming an integrated inductor over a substrate;

forming an aperture through said substrate from the back side of said substrate so that said aperture is located under said inductor; and

filling said aperture with a dielectric material.

Please add the following new claim:

The method of claim 1 including forming said aperture under said 21 (New).

> ice as first class mail with so the date indicated above and is addressed to the Commissioner for Patents, Washington DC 20231